

APPLICANT'S ART CITATION <small>(Use several sheets if necessary)</small> 	Application 10/772,546		OFGS File No. P/4178-11				
	Applicant Yusuke MURAOKA et al.						
	Filing Date February 5, 2004		Group Art Unit ---				
	U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2002-313764	10-2002	Japan			X	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Concise Explanation report					
Examiner		Date Considered					
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</small>							



P/4178-11

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Yusuke MURAOKA et al.
Serial No.: 10/772,546
Filed: February 5, 2004

New York, New York
Date: April 12, 2004
Group Art Unit:
Examiner:

For: A HIGH-PRESSURE PROCESSING APPARATUS AND HIGH-PRESSURE
PROCESSING METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the
convenience of the Examiner.

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James A. Finder

Name of applicant, assignee or
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Signature

April 12, 2004
Date of Signature

Respectfully submitted,

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Enclosures